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**\*BIBDATASHEET\***

Bib Data Sheet

CONFIRMATION NO. 4

SERIAL NUMBER 10/032,284	FILING DATE 12/21/2001  RULE	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO APPM/5192/02/CPI/COPPE
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## APPLICANTS

Ling Chen, Sunnyvale, CA;

Vincent Ku, San Jose, CA;

Dien-Yeh Wu, San Jose, CA; Hua Chung, San Jose, CA;

Alan Ouye, San Mateo, CA;

Norman Nakashima, Sunnyvale, CA;

## \*\* CONTINUING DATA \*\*\*\*\*

This appln claims benefit of 60/346,086 10/26/2001 *ku 9/17/03*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

*NONE 9/17/03 ku*

F REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/15/2002

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 7 ✓	TOTAL CLAIMS 105 ✓	INDEPENDENT CLAIMS 10 ✓
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after allowance	EXAMINER'S SIGNATURE <i>[Signature]</i>	INITIALS <i>[Initials]</i>		
Verified and Acknowledged				

## ADDRESS

32588  
APPLIED MATERIALS, INC.  
2881 SCOTT BLVD. M/S 2061  
SANTA CLARA, CA  
95050

## TITLE

Gas delivery apparatus and method for atomic layer deposition

FILING FEE

FEES: Authority has been given in Paper

☐ All Fees☐ 1.16 Fees ( Filing )